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By: *Linda E. Hastings*
LINDA E. HASTINGS

Any fee due as a result of this paper, not covered by an enclosed check, may be charged on Deposit Acct. No. 50-1290.

Attorney Docket No.: NECW 18.281 (100806-17349)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Toru TATSUMI

Serial No.: 09/744,701

Filed: January 29, 2001

Title: **METHOD OF VAPOR PHASE GROWTH OF
METAL OXIDE DIELECTRIC FILM AND
APPARATUS FOR VAPOR PHASE GROWTH OF
METAL OXIDE DIELECTRIC MATERIAL**

Examiner: H. Jey Tsai

Group Art Unit: 2812

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. 1.116

S I R :

In response to the Office Action mailed on April 29, 2004, the period for responding thereto having been set to expire after July 29, 2004, please amend the subject application as follows: